



Docket No.: OMY-013  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Kunie Ogata et al.

Application No.: 09/963,527

Group Art Unit: 1756

Filed: September 27, 2001

Examiner: J. Ruggles

For: RESIST PATTERN FORMING METHOD  
(amended)

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FEB 12 2004  
TC 1700

**SUPPLEMENTAL AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**  
**SUBMITTED WITH RCE**

**MS RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

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**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 8, 2003 (Paper No. 10), and the Advisory Action dated February 5, 2004 (Paper No. 01282004), and Supplemental to the Amendment filed January 8, 2004, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.